



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kittl et al.

Art Unit: 2829

Serial No.: 10/023,825

Examiner: Kobert, R.

Filing Date: 12/19/2001

Docket No.: TI-23892

Title: METHOD TO IMPROVE SILICIDE FORMATION ON POLYSILICON

ELECTION

Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

July 23, 2003

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner of Patents PO Box 1450, Alexandria, VA 22313-1450.

Date: 7-23-03
Marianna Smith
Marianna Smith

The Examiner required election between species (a), claims 1-4, species (b), claims 5-8, and species (c), claims 9-12. Applicant hereby elects species (a) with claims 1-4 readable thereon.

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Respectfully Submitted

Jacqueline J. Garner
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TECHNOLOGY CENTER
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